



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ammar Derraa

Serial No.: 10/654,226

Filed: September 2, 2003

**For: METHOD OF FABRICATING FIELD
EMISSION ARRAYS EMPLOYING A
HARD MASK TO DEFINE COLUMN
LINES AND ANOTHER MASK TO
DEFINE EMITTER TIPS AND RESISTORS**

Confirmation No.: 4741

Examiner: M. Santiago

Group Art Unit: 2879

**Attorney Docket No.: 2269-3882.8US
(99-0017.08/US)**

Notice of Allowance Mailed:

May 4, 2005

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL994848217US

Date of Deposit with USPS: August 3, 2005

Person making Deposit: Steven P. Wong

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

**Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450**

Examiner:

Please amend the above-referenced application as follows:

*Approved
for Entry
msk 8/24/05*